

IFW



Docket No.: 258184US0PCT

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

OBLON  
SPIVAK  
McCLELLAND  
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&  
NEUSTADT  
P.C.

ATTORNEYS AT LAW

RE: Application Serial No.: 10/510,964

Applicants: Akiko YOSHIDA, et al.

Filing Date: November 1, 2004

For: ION ADSORPTION MODULE AND WATER  
TREATMENT METHOD

Group Art Unit: 1724

Examiner: CINTINS, I. C.

SIR:

Attached hereto for filing are the following papers:

**Request for Reconsideration**

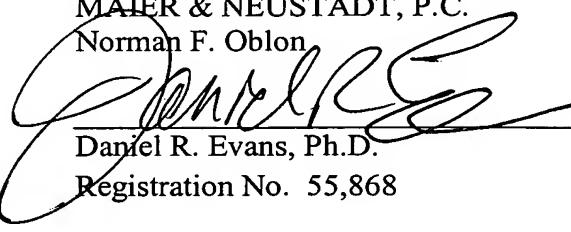
**English Translation of JP 2002-248504 w/ Translator's Certificate (Executed)**

Our check in the amount of \$0.00 is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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